



Docket No.: 050432-0395

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of

Akif SULTAN, et al.

Application No.: 10/759,171

Filed: January 20, 2004

: Customer Number: 20277

: Confirmation Number: 6644

: Group Art Unit: 2812

: Examiner: Isaac, Stanetta D.

For: METHOD OF FORMING MINIATURIZED POLYCRYSTALLINE SILICON GATE
ELECTRODES USING SELECTIVE OXIDATION

REQUEST FOR RECONSIDERATION

Mail Stop Request for Reconsideration
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Reconsideration of the rejection under 35 U.S.C. § 103 imposed in the Office Action
dated June 27, 2005 is solicited in light of the following Remarks.

*Please
Enter
SDE 8/18/05*